Attorney Docket No.: 0509-1090

Application No.:

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

Applicant:

NEW NATIONAL PHASE

Daniel ESTEVE et al.

(Use several sheets if necessary) Filing Date: Group Art Unit: April 22, 2005 **U.S. PATENT DOCUMENTS** Examiner **Document Number** Date Name Subclass Class Filing date Initial (if appropriate) **FOREIGN PATENT DOCUMENTS** Examiner **Document Number** Date Country Class Subclass Translation Initial Yes No MN 0 331 769 9/13/1989 **EUROPE** OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) CHU Z ET AL., "Silicon three-axial tactile sensor" SENSORS AND ACTUATORS A, ELSEVIER SEQUOIA MN S.A., LAUSANNE, CH, Vol. 54, No. 1-3 June 1, 1996, pages 505-510. **EXAMINER:** DATE CONSIDERED 03/12/2007 /Max Noori/

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Sheet <u>1</u> of <u>1</u>

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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Attorney Docket No.: 0509-1090

Application No.: 10/532,307

Applicant:

Daniel ESTEVE et al.

Filing Date: Group Art Unit: June 14, 2005 3731 **U.S. PATENT DOCUMENTS** Examiner **Document Number** Date Name Class Subclass Filing date Initial (if appropriate) MN 5,980,518 11/09/99 CARR ET AL **FOREIGN PATENT DOCUMENTS** Examiner **Document Number** Date Country Class Subclass Translation Initial Yes No MN WO 0207617 01/31/02 WIPO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) DARGAHI J ET AL: "A MICROMACHINED PIEZOELECTRIC TACTILE SENSOR FOR AN ENDOSCOPIC GRASPER-THEORY, FABRICATION AND EXPERIMENTS", JOURNAL OF MN MICROELECTROMECHANICAL SYSTEMS, IEEE INC. NEW YORK, US, VOL. 9, NR. 3, PAGE(S) 329-335 XP001010972 ISSN: 1057-7157 abrege: figures 1,2 **EXAMINER: DATE CONSIDERED** /Max Noori/ 03/12/2007

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